

AH150 HANDLING FOR SUBSTRATES

MOD. AH150 ARE FULLY AUTOMATIC LOADING & UNLOADING EQUIPMENTS FOR CERAMIC SUBSTRATES INTO CASSETTE OR STACK MAGAZINES. THEY CAN BE EASILY CONNECTED TO SEVERAL MACHINES AS PICK & PLACE, SCREEN PRINTING MACHINE, LASERS, REFLOW, TESTING MACHINE, ETC....

DIFFERENT TYPES OF CASSETTE OR STACK ARE ACCEPTED WITH SIMPLE ADAPTORS: AUR°EL ,BACCINI, EKRA, etc..

SUBSTRATE DIMENSION: UP TO 6"X6"



AH150C

AH150S

SPECIFICATIONS

Loading/Unloading level :	900 mm ± 20 mm
Substrate dimension :	min 2"x2" max 6"x6" non standard or odd form are also possible
Control system :	P.L.C.
Power Supply :	220 V (50-60 Hz) 1 Amp/unit Compressed air 5 ATM

C	cassette	1	single	substrate dimension
S	stack	2	shuttle	-

Order example: AH150/C/2/4"x4"

OTHER HANDLINGS:

TRANSPORTATION UNIT, BUFFER, INVERTER, COMPLETE AUTOMATION.